

**Notice of References Cited**

Application/Control No.

09/623,516

Applicant(s)/Patent Under

Reexamination

KIM ET AL.

Examiner

Aaron W Carter

Art Unit

2625

Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,125,198 A	09-2000	Onda, Katsumasa	382/154
	B	US-6,141,440 A	10-2000	Melen, Roger D.	382/154
	C	US-6,606,406 B1	08-2003	Zhang et al.	382/154
	D	US-6,215,899 B1	04-2001	Morimura et al.	382/154
	E	US-6,314,211 B1	11-2001	Kim et al.	382/285
	F	US-2002/0012459	01-2002	Oh, Seung-Ho	382/154
	G	US-4,745,562	05-1988	Prazdny, Kvetoslav F.	702/71
	H	US-4,825,393	04-1989	Nishiya, Takushi	702/152
	I	US-5,734,743	03-1998	Matsugu et al.	382/154
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.